



S/N 10/004714

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Scott G. Meikle et al. Examiner: Ginette Peralta
Serial No.: 10/004,714 Group Art Unit: 2814
Filed: December 5, 2001 Docket No: 303.444US5
Title: METHOD OF DEPOSITING TUNGSTEN NITRIDE USING A SOURCE GAS
COMPRISING SILICON

PETITION FOR A ONE-MONTH EXTENSION OF TIME

MS RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

9 ext (U)
M. Braun
5/14/03

In accordance with the provision of 37 CFR § 1.136(a), it is respectfully requested that a one-month extension of time be granted in which to respond to the Final Rejection mailed January 15, 2003, said period of response being extended from April 15, 2003 to May 15, 2003.

Our check in the amount of \$110.00 is enclosed to cover the required extension fee.
Please charge any additional fees or credit overpayment to deposit Account No. 19-0743.

Respectfully Submitted

SCOTT G. MEIKLE ET AL.

By their Representatives,

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MAY 20 2003
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Date: 5-13-03

By:

Marvin L. Beekman
Reg. No: 38,377

CERTIFICATE UNDER 37 CFR § 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelop addressed to: MS RCE; Commissioner for Patents, P.O Box 1450, Alexandria, VA 22313-1450, on this 13th day of May 2003

Name:

Amy Moriarty

Signature:

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